

**PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q76454

Shinji YOKONO, *et al.*

Appln. No.: 10/611,961

Confirmation No.: 3574

Group Art Unit: 1762

Filed: July 3, 2003

Examiner: James LIN

For: METHOD FOR MANUFACTURING PLASMA DISPLAY PANEL, INSPECTION
METHOD FOR INSPECTING PHOSPOR LAYER AND INSPECTION APPARATUS
FOR INSPECTING PHOSPHOR LAYER

AMENDMENT UNDER 37 C.F.R. § 1.114(c)

MAIL STOP RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 9, 2007, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS.....	2
REMARKS.....	5